



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of: **KIRA, et al.**

Group Art Unit: **2822**

Serial No.: **08/897,953**

Examiner: **David E. GRAYBILL**

Filed: **July 24, 1997**

P.T.O. Confirmation No.: 5157

For: **METHOD AND SYSTEM FOR FABRICATING A SEMICONDUCTOR DEVICE**

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 3, 2006

Sir:

In response to the Office Action dated **January 13, 2006**, please amend the above-identified application as follows: